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(54) Title: PROCESS AND APPARATUS FOR MONITORING SURFACE LASER CLEANING

(57) Abstract

A process and apparatus for monitoring the cleanign of a surface (1) by laser irradiation include illuminating the surface (1) to be cleaned, being cleaned or having been cleaned by ultra–violet irradiation provided either by the cleaning laser or by a further source (5) sufficient to excite into fluorescence contaminants (10, 11) on the surface (1) which fluoresce under ultra–violet irradiation.

